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| Notice of References Cited | Application/Control No. 10/636,131 | Applicant(s)/Patent Under Reexamination JEONG ET AL. | |
| | Examiner Jennifer M. Kennedy | Art Unit 2812 | Page 1 of 1 |

U.S. PATENT DOCUMENTS

| * | | Document Number Country Code-Number-Kind Code | Date MM-YYYY | Name | Classification |
|---|---|--|-----------------|------------------|----------------|
| | A | US-6,281,073 B1 | 08-2001 | Lee, Young Jun | 438/255 |
| | B | US-2002/0115256 A1 | 08-2002 | Lee et al. | 438/262 |
| | C | US-2003/0235948 A1 | 12-2003 | Park, Je-min | 438/253 |
| | D | US-6,080,620 A | 06-2000 | Jeng, Erik S. | 438/253 |
| | E | US-6,350,707 B1 | 02-2002 | Liu et al. | 438/791 |
| | F | US-6,372,575 B1 | 04-2002 | Lee et al. | 438/253 |
| | G | US-6,255,160 B1 | 07-2001 | Huang, Jenn Ming | 438/253 |
| | H | US- | | | |
| | I | US- | | | |
| | J | US- | | | |
| | K | US- | | | |
| | L | US- | | | |
| | M | US- | | | |

FOREIGN PATENT DOCUMENTS

| * | | Document Number Country Code-Number-Kind Code | Date MM-YYYY | Country | Name | Classification |
|---|---|--|-----------------|---------|------|----------------|
| | N | | | | | |
| | O | | | | | |
| | P | | | | | |
| | Q | | | | | |
| | R | | | | | |
| | S | | | | | |
| | T | | | | | |

NON-PATENT DOCUMENTS

| * | | Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages) |
|---|---|---|
| | U | |
| | V | |
| | W | |
| | X | |

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